ATTY DOCKET NO.: CCF-5519NP2 SERIAL NO. TBD **FORM PTO-1449** U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE (REV. 6-89) INFORMATION DISCLOSURE APPLICANT(S): Shuvo Roy et al. STATEMENT BY APPLICANT (Use several sheets if necessary) GROUP: TBD FILING DATE: Concurrently Herewith **U.S. PATENT DOCUMENTS EXAMINER FILING DATE IF** SUB INITIAL DOCUMENT NUMBER DATE NAME **CLASS APPROPRIATE** CLASS Jun. 20, 1995 Kovacevic et al. Α US-5,425,775 В Oct. 10, 1995 Yen et al. US-5,456,724 Nov. 28, 1995 C US-5,470,354 Hershberger et al. Jul. 2, 1996 Lesinski et al. D US-5,531,787 Dec. 1, 1998 Ε US-5,843,082 Yuan et al. F US-6,034,296 Mar. 7, 2000 Elvin et al. G US-6,036,693 Mar. 14, 2000 Yuan et al. May 9, 2000 Perusek Н US-6,059,784 US-6,342,074 Jan. 29, 2002 Simpson 1 J US-6,447,448 Sep. 10, 2002 Ishikawa et al. ĸ FOREIGN PATENT DOCUMENTS **TRANSLATION** SUB DOCUMENT NUMBER DATE COUNTRY **CLASS** CLASS L М N OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) IEEE Transactions on Biomedical Engineering, Vol. 47, No. 1, January 2000 "A PORTABLE MICROSYSTEM-BASED TELEMETRIC PRESSURE AND TEMPERATURE MEASUREMENT UNIT", 0 Bernd B. Flick and Reinhold Orglmeister. Med. Eng. Phys. Vol. 19, No. 6, pp. 539-546, 1997 "COMPARISON OF LOADS ON INTERNAL SPINAL FIXATION DEVICES MEASURED IN VITRO AND IN VIVO", A. Rohlmann, G. Bergmann, F. Graichen and U. Weber. Journal of Microelectromechanical Systems, Vol. 9, No. 1, March 2000, A MINIATURE PRESSURE O SYSTEM WITH A CAPACITIVE SENSOR AND A PASSIVE TELEMETRY LINK FOR USE IN IMPLANTABLE APPLICATIONS", Stavros Chatzandroulis, Dimitris Tsoukalas and Peter A. Neukomm. R "INTRODUCTION TO MEMS", M. Mehregany and S. Roy. SPINE Volume 25, Number 20, pp. 2595-2600 "REAL-TIME IN VIVO LOADING IN THE LUMBAR S SPINE" "Part 1. Interbody Implant: Load Cell Design and Preliminary Results", Eric H. Ledet, MS, Barton L. Sachs, MD, John B. Brunski, PhD, Charles E. Gatto, MD, and Peter S. Donzelli, PhD. **EXAMINER DATE CONSIDERED** 75.a S2 2-8-06 EXAMINER: Initial if citation considered, whether or not citati n is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next

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